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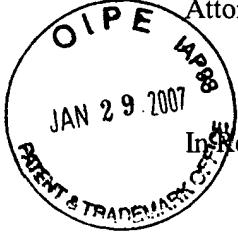
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January 23, 2007	Flor S. Neafus		1-23-07
Date Mailed	Name	Signature	Date

Attorney's Docket No. 42P10077D2

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Patent Application of:)
Qing Ma et al.) Examiner: Dougherty, Thomas M.
Application No.: 10/763,779) Art Unit: 2834
Filed: January 22, 2004)
For: MICRO-ELECTROMECHANICAL)
STRUCTURE RESONATOR FREQUENCY)
ADJUSTMENT USING RADIANT ENERGY)
TRIMMING AND LASER/FOCUSED ION)
BEAM ASSISTED DEPOSITION)
)

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Commissioner for Patents
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Enclosed is a copy of Information Disclosure Citation Form PTO-1449 or PTO/SB/08 together with copies of the documents cited on that form. It is respectfully requested that the cited documents be considered and that the enclosed copy of Information Disclosure Citation Form PTO-1449 or PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

Pursuant to 37 C.F.R. § 1.97, the submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made and is not to be construed as an admission that the information cited in this statement is material to patentability.

Pursuant to 37 C.F.R. § 1.97, this Information Disclosure Statement is being submitted under one of the following (as indicated by an "X" to the left of the appropriate paragraph):

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- A check for \$180.00 for the fee under 37 C.F.R. § 1.17(p).
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If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: 1-23-07

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Substitute for Form 1449/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

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Sheet	1	of	1	Attorney Docket Number	42P10077D2
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Complete if Known

Application Number	10/763,779
Filing Date	January 22, 2004
First Named Inventor:	Qing Ma et al.
Art Unit	2834
Examiner Name	Thomas M. Dougherty

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
	1.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 06/15/2004. (42P10077)	
	2.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 12/17/2004. (42P10077)	
	3.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 11/30/2005. (42P10077)	
	4.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 06/01/2006. (42P10077)	
	5.	Application No. 09/738,118, Filing date 12/15/2000, Qing Ma et al., "A PROCESS OF MAKING A MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR WITH FREQUENCY ADJUSTMENT," Office Action mailed 10/06/2006. (42P10077)	
	6.	Application No. 10/386,062, Filing date 03/10/2003, Qing Ma et al., "MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR FREQUENCY ADJUSTMENT USING RADIANT ENERGY TRIMMING AND LASER/FOCUSED ION BEAM ASSISTED DEPOSITION," Office Action mailed 09/15/2003. (42P10077D)	
	7.	Application No. 10/386,062, Filing date 03/10/2003, Qing Ma et al., "MICRO-ELECTROMECHANICAL STRUCTURE RESONATOR FREQUENCY ADJUSTMENT USING RADIANT ENERGY TRIMMING AND LASER/FOCUSED ION BEAM ASSISTED DEPOSITION," Office Action mailed 12/04/2003. (42P10077D)	
	8.	Application No. 10/804,897, Filing date 03/19/2004, Qing Ma et al., "PROCESS FOR TUNING AN OSCILLATOR," Office Action mailed 12/13/2005. (42P10077D3)	
	9.	Application No. 10/804,897, Filing date 03/19/2004, Qing Ma et al., "PROCESS FOR TUNING AN OSCILLATOR," Office Action mailed 10/05/2006. (42P10077D3)	

Examiner Signature	Date Considered
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English Translation is attached.

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